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**Date:** June 17, 2004 **Pages (including cover):** 2

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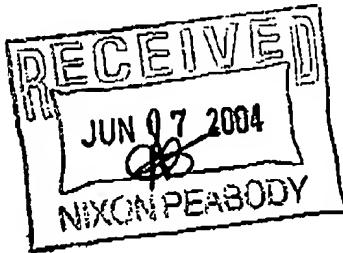


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CONFIRMATION NO. 2927

FILING RECEIPT



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## Applicant(s)

Osamu Nakamura, Atsugi, JAPAN;

## Assignment For Published Patent Application

Semiconductor Energy Laboratory Co., Ltd., Atsugi-shi, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2003-086384 02/26/2003

03

If Required, Foreign Filing License Granted: 06/04/2004

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Early Publication Request: No

## Title

Plasma treatment apparatus